Special Issue

Recent Advances in Micro/Nano-Fabrication

Message from the Guest Editors

In recent decades, micro/nano-fabrication technologies have been widely used to prepare non-destruction testing transducers, semiconductors, special functional surfaces, and medical interventional key components. These kinds of micro/nano-fabrication technologies include traditional cutting/dicing, laser machining, micro-3D printing, printed circuits, chemical machining, and optical machining. Micro/nano-fabrication technologies are the key factors with which to determine the functions of micro/nano-devices. We are pleased to invite you to submit your recent research papers and reviews on the micro/nano-fabrication, construction, performance, and functional integration of microdevices, as well as their multiple applications. This Special Issue aims to collect and present the recent advances in micro/nano-fabrication, as well as provide deep insights for future works. In this Special Issue, original research articles and reviews are welcome. Research areas may include (but not limited to) micro/nano-materials and processing as well as related engineering and technology. I/We look forward to receiving your contributions.

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You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

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